# Effect of End Group Chemistry on Surface Molecular Motion of Monodisperse Polystyrene Films

Tisato Kajiyama\*, Noriaki Satomi, Yasuyuki Yokoe, Daisuke Kawaguchi, Keiji Tanaka, Atsushi Takahara

Graduate School of Engineering, Kyushu University, 6-10-1 Hakozaki, Higashi-ku, Fukuoka 812-8581, Japan

SUMMARY: The surface molecular motion of monodisperse polystyrene (PS) with various chain end groups was investigated on the basis of temperature-dependent scanning viscoelasticity microscope (TDSVM). The surface glass transition temperatures,  $T_g^s$ s for the proton-terminated PS (PS-H) films with number-average molecular weight,  $M_n$  of 4.9k - 1,450k measured by TDSVM measurement were smaller than those for the bulk one, with corresponding  $M_n$ s, and the  $T_g$ s for  $M_n$  smaller than ca. 50k were lower than room temperature (293 K). In the case of  $M_n = \text{ca. } 50\text{k}$ , the  $T_s$ 's for the  $\alpha, \omega$ -diamino-terminated PS  $(\alpha, \omega$ -PS(NH<sub>2</sub>)<sub>2</sub>) and  $\alpha, \omega$ dicarboxy-terminated PS  $(\alpha, \omega$ -PS(COOH)<sub>2</sub>) films were higher than that of On the other hand, the  $T_g^s$  for the  $\alpha,\omega$ -perfluoroalkylsilylterminated PS  $(\alpha, \omega$ -PS(SiC<sub>2</sub>C<sup>F</sup><sub>6</sub>)<sub>2</sub>) film with the same  $M_n$  was much lower than those for the PS films with all other chain ends. The change of  $T_o^s$ for the PS film with various chain end groups can be explained in terms of the depth distribution of chain end groups at the surface region.

#### Introduction

Glass transition temperature,  $T_{\rm g}$  is the fundamental parameter of polymeric solids which is closely related to the state of thermal molecular motion. In the case of ultrathin polymer films, the glass transition behavior has been evaluated based on spectroscopic ellipsometry<sup>1</sup>, X-ray reflectivity<sup>2</sup>, and Brillouin light scattering<sup>3</sup>. These measurements revealed that the magnitude of  $T_{\rm g}$  for the ultrathin film depended on the film thickness and the state of interaction between polymer chain and substrate. Since these measurements were based on the temperature change in average physicochemical properties of polymer ultrathin films, it is difficult to measure the molecular motion of polymer film at the outermost surface region.

Scanning force microscopy (SFM) can directly evaluate the physicochemical properties at the outermost surface region on the basis of the deflection and torsion of the cantilever which reflect atomic force, adhesion, friction, magnetic or chemical

interaction between tip and polymer surface. In our previous study, the surface relaxation process for the monodisperse polystyrene (PS) films with different number-average molecular weights,  $M_n$ s had been investigated by lateral force microscopy (LFM)<sup>4)</sup> and scanning viscoelasticity microscopy (SVM)<sup>5)</sup>. From the temperature change in the shift factors used in the formation of the master curve, the apparent activation energy for the surface  $\alpha_a$ -relaxation process of the monodisperse PS film was found to be approximately half that for the bulk one<sup>6)</sup>. The purpose of this study is to evaluate the influence of the chain end chemistry on the magnitude of surface  $T_g$ ,  $T_g^s$  for the monodisperse PS films with various  $M_n$ s on the basis of temperature-dependent SVM (TDSVM)<sup>7)</sup>.

## **Experimental**

The polymers used in this study were monodisperse four kinds of PSs with various chain end chemistry, and were synthesized by a living anionic polymerization. Table I tabulates the  $M_n$ , the molecular weight dispersity,  $M_w/M_n$ , and the bulk  $T_g$ ,  $T_g^b$  for four kinds of PSs. The  $T_g^b$  was evaluated on the basis of differential scanning calorimetric (DSC) measurement at a heating rate of 10 K min<sup>-1</sup> under a dry nitrogen purge. The monodisperse sample was used in order to avoid the influence on

Table I	Characterizations	of four kinds	of PCc uce	d in this study
Table I.	Unaracterizations	OF TOUR KINGS	S OF PAS USE	a in inis siliav.

Sample	$M_{\mathbf{n}}$	$M_{\rm w}/M_{\rm n}$	$T_{\rm g}^{\rm \ b}/{\rm K}$
PS-H	4.9k	1.09	362
	30k	1.08	374
	54k	1.03	377
	90k	1.05	378
	250k	1.03	379
	1,450k <sup>a)</sup>	1.06	380
$\alpha, \omega - PS(NH_2)_2$	23k	1.08	375
~ ~ ~	52k	1.08	378
$\alpha,\omega$ - PS(COOH) <sub>2</sub>	12k <sup>b)</sup>	1.09	385
	52k <sup>b)</sup>	1.08	382
$\alpha, \omega - PS(SiC_2CF_6)_2$	25k	1.12	373
2 0.2	48k	1.17	377
	93k	1.17	379

<sup>&</sup>lt;sup>a</sup>Purchased from Pressure Chemical Co., Ltd.

<sup>&</sup>lt;sup>b</sup>Purchased from Polymer Source. Inc.

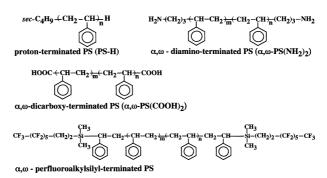


Fig. 1: Chemical structure of PSs with various chain end groups.

surface migration of lower  $M_n$  in polydisperse sample. Fig. 1 shows the chemical structure of the PSs with various chain end groups. The PS films were coated from a toluene solution onto cleaned silicon wafer by a spin-coating method. The film thickness evaluated by ellipsometric measurement was ca. 200 nm. films were annealed at 423 K for 24 hrs under vacuum to achieve the thermal equilibrium state. In order to investigate the surface molecular motion of these PS films, the surface dynamic viscoelastic function, in other words, the surface phase lag between dynamic deformation and force signals was measured as a function of temperature based on TDSVM. TDSVM equipment was SPA 300HV (Seiko Instruments Industry Co., Ltd.) with an SPI 3800 controller. measurement was carried out at various temperatures in vacuo under a reference force of  $\sim 1$  nN (repulsive force). The modulation frequency and the modulation amplitude at the supporting part of the cantilever were 4 kHz and 1.0 nm, A commercially available silicon nitride (Si<sub>3</sub>N<sub>4</sub>) tip on a rectangular cantilever with the bending spring constant of 0.09 N m<sup>-1</sup> (Olympus Co., Ltd.) was used.

#### **Results and Discussion**

Fig. 2 shows the temperature dependence of the surface phase lag,  $\delta^s$  between imposed stimulation displacement and detected response force signals, and the bulk  $\tan \delta$  for the monodisperse proton-terminated PS (PS-H) films with  $M_n$ s of 4.9k, 30k, 54k, 90k, 250k, and 1,450k. The temperature dependence of bulk  $\tan \delta$  was obtained by Rheovibron (DDV-01FP, Orientec A&D Co., Ltd.) at 3.5 Hz. Though it might be possible that the measured  $\delta_s$  contains the contribution of the phase lag from the mechanical vibration system<sup>8</sup>, the calibration has not been done at the

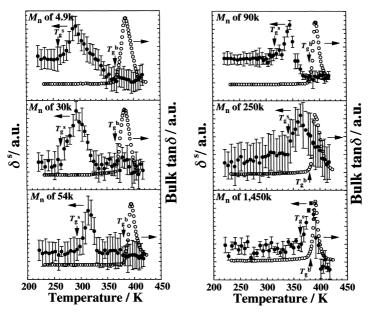


Fig. 2: Temperature dependence of surface phase lag,  $\delta^s$  and bulk  $\tan \delta$  for the PS-H films with different  $M_n$ s.

present time because of the difficulty in determination of the calibration constant. However, it seems reasonable to compare quantitatively the temperature dependence of the  $\delta^s$  and the bulk  $\tan \delta$  to decide the  $T_g^s$  and the  $T_g^b$  since the calibration constant might not change so much in the temperature range around these  $T_g^s$ s. shows the  $\alpha_a$  loss peaks corresponding to the surface and bulk micro-Brownian motion of polymeric chains, respectively. The peaks of  $\delta^{s}$ s appeared in a lower temperature region than those bulk  $\tan \delta$ s, though the  $\delta$ s and the bulk  $\tan \delta$  were measured at 4 kHz and 3.5 Hz, respectively. The threshold temperature, that is, the temperature at which the magnitude of  $\delta^{s}$  or bulk  $\tan \delta$  starts to increase, can be empirically used as the surface or bulk  $T_{g}s^{9}$ . Then, in this study, this threshold temperatures of the  $\delta^{\rm s}$  and the bulk  $\tan\delta$  were defined as  $T_{\rm g}^{\rm s}$  and  $T_{\rm g}^{\rm b}$ , respectively. The  $T_g^s$  and  $T_g^b$  are shown by arrows in Fig. 2. The  $T_g^s$ s were more apparently shifted to a higher temperature with an increase in  $M_n$  than  $T_g^b$ s, as shown in Fig. 2. Therefore, it seems reasonable to conclude that the surface thermal molecular motion is more activated in comparison with the bulk one. Also, the  $T_g^s$  for the PS-H film was strongly dependent on the  $M_n$  as compared with the bulk one. These results indicate that the surface molecular motion of the monodisperse PS-H film is closely related to the concentration of chain end groups at the film surface. Since the magnitudes of the  $T_{\rm g}^s$  for the PS-H films with  $M_{\rm n}$  lower than ca. 50k were below 293 K, it seems reasonable to conclude that the PS-H films surface with  $M_{\rm n}$  lower than ca. 50k is in a glass-rubber transition state or a rubbery state, even at room temperature, 293 K. The  $T_{\rm g}^s$  asymptotically approaches the bulk one with an increase in  $M_{\rm n}$  and the  $T_{\rm g}^s$  for high  $M_{\rm n}$  of ca. 1,000k was slightly lower than the bulk one. Therefore, these results apparently indicate that a reduction of  $T_{\rm g}^s$  of PS-H in comparison with  $T_{\rm g}^b$  may be caused by an increased free volume at the surface due to the preferential surface enrichment of chain end groups as well as the decrease in number of chain entanglement density<sup>10</sup>. Also, these results support our previous result that the magnitude of activation energy for the surface  $\alpha_a$ -relaxation process at the airpolymer interface was almost half as much as that for the bulk one, maybe due to an extra freedom for the active thermal segmental motion of PS chains at the airpolymer interface<sup>6</sup>.

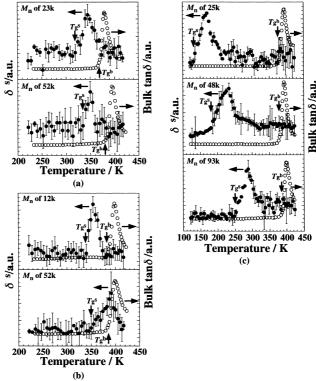


Fig. 3: Temperature dependence of  $\delta^s$  and bulk  $\tan \delta$  for (a)  $\alpha, \omega$ -PS(NH<sub>2</sub>)<sub>2</sub>, (b)  $\alpha, \omega$ -PS(COOH)<sub>2</sub> and (c)  $\alpha, \omega$ -PS(SiC<sub>2</sub>C<sup>F</sup><sub>6</sub>)<sub>2</sub> films.

The previous results revealed that the surface molecular motion of the monodisperse PS-H film was closely related to the distribution of chain end groups at the outermost However, the surface molecular motion of the PS film with different kind of chain end groups has not been evaluated yet111). PSs with both chain end groups of amino, carboxyl, and fluoroalkylsilyl groups were prepared, and the  $T_g$ s of these PSs were measured based on TDSVM. Fig. 3 shows the temperature dependence of the  $\delta^{\rm s}$  and the bulk  $\tan \delta$  for (a) the  $\alpha, \omega$ -diamino-terminated PS ( $\alpha, \omega$ - $PS(NH_2)_2$ ) films with  $M_n$ s of 23k and 52k, (b) the  $\alpha, \omega$ -dicarboxy-terminated PS  $(\alpha, \omega - PS(COOH)_2)$  films with  $M_n$ s of 12k and 52k, and (c) the  $\alpha, \omega$ perfluoroalkylsilyl-terminated PS  $(\alpha, \omega$ -PS(SiC<sub>2</sub>C<sup>F</sup><sub>6</sub>)<sub>2</sub>) films with  $M_n$ s of 25k, 48k and The peaks of  $\delta^s$ , which correspond to the surface  $\alpha_s$ -relaxation process, were 93k. similarly observed on the  $\delta^s$ -temperature curves of all kinds of PSs and appeared in a lower temperature region than those of bulk tan &s, as shown in Fig. 3 (a), (b) and (c). As mentioned above, it is empirically accepted that the threshold temperature of  $\delta^s$ and bulk  $\tan \delta$  were decided as  $T_{\rm g}^{\rm s}$  and  $T_{\rm g}^{\rm b}$ , respectively. In the same manner as PS-H, the magnitude of the  $T_g^s$  for the  $\alpha,\omega$ -PS(NH<sub>2</sub>)<sub>2</sub>,  $\alpha,\omega$ -PS(COOH)<sub>2</sub> and  $\alpha,\omega$ - $PS(SiC_2C_6^F)_2$  films was lower than the bulk one. However, these  $T_g^s$ s at the same  $M_{\rm n}$  ( $M_{\rm n}$  = ca. 50k) were strongly depended on the end group chemistry. same  $M_n$ , the  $T_g^s$  for the  $\alpha,\omega$ -PS(NH<sub>2</sub>)<sub>2</sub> and  $\alpha,\omega$ -PS(COOH)<sub>2</sub> films were higher than that for the PS-H film. On the other hand, a larger depression of  $T_g^s$  for the  $\alpha, \omega$ -PS(SiC<sub>2</sub>C<sup>F</sup><sub>6</sub>)<sub>2</sub> film than those of PSs with other chain end groups was observed.

Fig. 4 shows the molecular weight dependence of the surface and bulk  $T_{\rm g}$ s for the monodisperse PS films with various chain end groups. The  $T_g$ 's of  $\alpha, \omega$ -PS(NH<sub>2</sub>)<sub>2</sub> and  $\alpha, \omega$ -PS(COOH)<sub>2</sub> were higher than those of PS-H with corresponding  $M_n$ . Since both chain end groups for  $\alpha, \omega$ -PS(NH<sub>2</sub>)<sub>2</sub> and  $\alpha, \omega$ -PS(COOH)<sub>2</sub> have higher surface free energy in comparison with the main chain part, the chain end groups are depleted from the surface region. Also, because  $\alpha, \omega$ -PS(COOH)<sub>2</sub>s are intermolecularly associated by hydrogen bonding, the apparent molecular weight of α,ω-PS(COOH), increases or the networks of PS chains were formed, resulting in a decrease in surface molecular motion. Thus, it seems reasonable to conclude that the  $T_g^s$ s of  $\alpha, \omega$ -PS(COOH)<sub>2</sub> were higher than those of  $\alpha, \omega$ -PS(NH<sub>2</sub>)<sub>2</sub> and PS-H at the same  $M_n$ . On the other hand, the  $T_g^s$ s of  $\alpha, \omega$ -PS(SiC<sub>2</sub>C<sup>F</sup><sub>6</sub>)<sub>2</sub> film with all  $M_n$ s were much lower than the bulk one and that for the PS-H film. fluoroalkylsilyl end group is more hydrophobic than the main chain part and the secbutyl and -CH<sub>2</sub>-CH<sub>2</sub>(C<sub>6</sub>H<sub>5</sub>) groups, which are the chain end group of PS-H, the surface free energy of fluoroalkylsilyl end group is lower than that of PS-H.

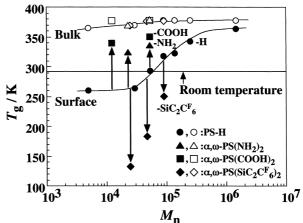


Fig. 4: Molecular weight dependence of surface and bulk  $T_{\rm g}$ s for the PS films with various chain end groups. The filled and open symbols denote the data for the  $T_{\rm g}^{\rm s}$  and  $T_{\rm g}^{\rm b}$ , respectively.

Therefore, a larger depression of  $T_g^s$  for the  $\alpha,\omega$ -PS(SiC<sub>2</sub>C<sup>F</sup><sub>6</sub>)<sub>2</sub> film than that of PS-H was explained by the intensive surface localization of fluoroalkylsilyl end group compared with other kind of PSs. In the case of the  $\alpha,\omega$ -PS(SiC<sub>2</sub>C<sup>F</sup><sub>6</sub>)<sub>2</sub> film, this intensive surface localization of fluoroalkylsilyl end group in the surface layer less than  $\sim 1$  nm was confirmed on the basis of angular-dependent X-ray photoelectron spectroscopic (ADXPS) measurement.

### Conclusion

The molecular weight dependences of the  $T_{\rm g}^{\rm s}$  for the monodisperse PS film with various chain end groups were evaluated by TDSVM measurement. The  $T_{\rm g}^{\rm s}$ s for the various chain end group terminated PS film were much lower than the bulk ones, and the  $T_{\rm g}^{\rm s}$  was strongly dependent on a difference of surface free energy between chain end group and main chain. The difference of  $T_{\rm g}^{\rm s}$  was explained by the surface concentration of chain end groups which is closely related to the free volume fraction.

#### References

- 1. J. L. Keddie, R. A. L. Jones, R. A. Coury, Europhys. Lett. 27, 59 (1994)
- W. J. Orts, J. H. van Zanten, W. L. Wu, S. K. Satija, *Phys. Rev. Lett.* 71, 867 (1993)

- J. A. Forrest, K. Dalnoski-Veress, J. R. Stevens, J. R. Dutcher, *Phys. Rev. Lett.* 77, 2002 (1996)
- (a) T. Kajiyama, K. Tanaka, A. Takahara, Macromolecules 30, 280 (1997), (b) K. Tanaka, A. Takahara, T. Kajiyama, Macromolecules 30, 6626 (1997)
- (a) T. Kajiyama, K. Tanaka, I. Ohki, S. R. Ge, S. J. Yoon, A. Takahara, Macromolecules 27, 7932 (1994), (b) K. Tanaka, A. Taura, S. R. Ge, A. Takahara, T. Kajiyama, Macromolecules 29, 3040 (1996)
- T. Kajiyama, K. Tanaka, N. Satomi, A. Takahara, Macromolecules 31, 5150 (1998)
- 7. N. Satomi, A. Takahara, T. Kajiyama, Macromolecules 32, 4474 (1999)
- 8. N. A. Burnham, G. Gremaud, A. J. Kulik, P. J. Gallo, F. Oulevey, *J. Vac. Sci. Technol. B* 14, 1308 (1996)
- 9. N. Saitô, K. Okano, S. Iwayanagi, T. Hideshima, in: *Solid State Physics* Vol.14, F. Seitz, D. Turubull, Eds., Academic Press, New York and London 1963, p.343
- 10. H. R. Brown, T. P. Russell, Macromolecules 29, 798 (1996)
- K. Tanaka, X. Jiang, K. Nakamura, A. Takahara, T. Kajiyama, T. Ishizone, A. Hirao, S. Nakahama, *Macromolecules* 31, 5148 (1998)